



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

~~PATENT~~ Application of:
Feltsman, et al.

Serial No.: 10/702,230

Filed: November 6, 2003

Confirmation No.: 7955

For: METHOD FOR DETECTING THE POSITION OF A SHUTTER DISK IN A PHYSICAL VAPOR DEPOSITION CHAMBER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1753

Examiner: to be assigned

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on May 6, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

21

Signature

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Respectfully submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/702,230	11/06/2003	1753	770	6452D02/CMI/L/B/PJS	4 ✓	12 ✓	2 ✓

Patent Counsel
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CONFIRMATION NO. 7955

FILING RECEIPT



OC000000011828337

Date Mailed: 02/05/2004

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Applicant(s)

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Assignment For Published Patent Application

Applied Materials, Inc.; ✓

Domestic Priority data as claimed by applicant ✓ ✓

This application is a DIV of 10/082,480 02/20/2002 PAT 6,669,829

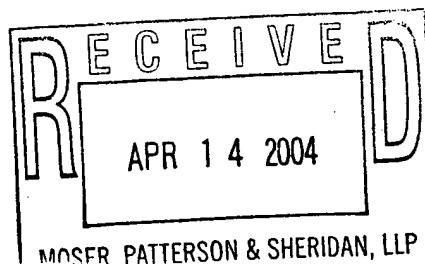
Foreign Applications

If Required, Foreign Filing License Granted: 02/03/2004

Projected Publication Date: 05/13/2004

Non-Publication Request: No

Early Publication Request: No



Title

Method for detecting the position of a shutter disk in a physical vapor deposition chamber

Preliminary Class

204

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